



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Toru TAKAYAMA et al.

Serial No. 10/650,046

Filed: August 28, 2003

For: MANUFACTURING METHOD FOR A  
SEMICONDUCTOR DEVICE AND  
HEAT TREATMENT METHOD  
THEREFOR

) Group Art Unit: 2813

) Examiner: T. Nguyen

) CERTIFICATE OF MAILING  
I hereby certify that this correspondence is  
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Commissioner for Patents, P.O. Box 1450,  
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Ashley M. Stamps

**RESPONSE TO ELECTION REQUIREMENT**

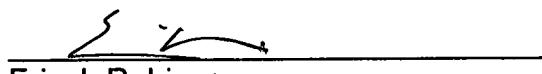
Honorable Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the election requirement in the Official Action mailed September 8, 2004, Applicant hereby elects without traverse Species 1, drawn to a method for forming a semiconductor device. Claims 1-57 read on the elected species.

Examination on the merits is requested.

Respectfully submitted,

  
Eric J. Robinson  
Reg. No. 38,285

Robinson Intellectual Property Law Office, P.C.  
PMB 955  
21010 Southbank Street  
Potomac Falls, Virginia 20165  
(571) 434-6789